



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 9, 2024	
IGI Report Number	LG647435668
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.10 - 8.13 X 5.04 MM

GRADING RESULTS

Carat Weight	2.01 CARATS
Color Grade	G
Clarity Grade	VVS 1
Cut Grade	IDEAL

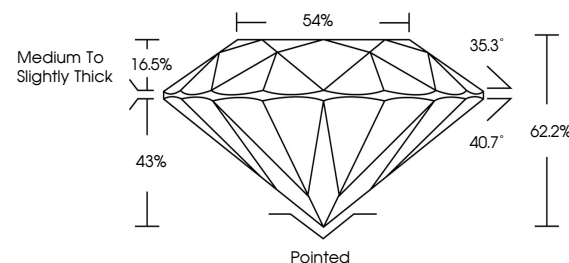
ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	15 LG647435668

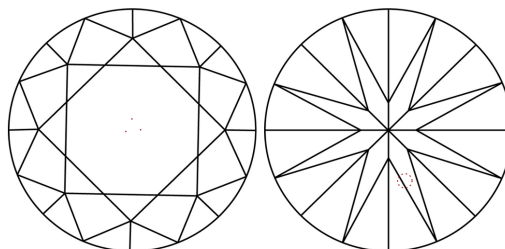
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG647435668
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VS ^{1,2}	VS ^{1,2}	SI ^{1,2}	I ^{1,3}
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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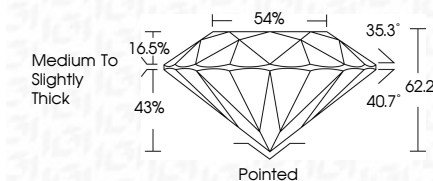
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 ROUND BRILLIANT

2.01 CARATS	G
VVS 1	
IDEAL	
62.2%	
54%	
Medium To Slightly Thick	
Pointed	
VERY GOOD	
VERY GOOD	
NONE	

ROUND BRILLIANT	10 - 13 x 5.04 MM	201 CARATS	VS 1	62.2%	54%	Medium To Slightly Thick	Pointed	VERY GOOD	VERY GOOD	NONE	FLUORESCENCE	
	Carat Weight		Clarity Grade	Color Grade	Cut Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence

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(CVD) growth process.